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In Affiliation with
Weiss, Moy & Harris, PC
having offices in Arizona and Nevada,
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Rabin & Berdo, PC

October 7, 2003

Mail Stop: PATENT APPLICATION

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Attorney Reference: SUND 485

Re: New Patent Application of: Chien-Sheng Yang

Title: COMPLEMETRAY METAL OXIDE SEMICONDUCTOR IMAGE SENSOR
AND METHOD OF MANUFACTURING THE SAME

Sir:

Please find attached hereto an application for patent that includes:

- ☒ Specification, Claims and Abstract (21 Pages)
- ☒ 5 Sheets of Formal Drawings (Figs. 1-4)
- ☒ Inventor's Declaration and Power of Attorney (2 Pages)
- ☒ Claim for priority and Priority document
- ☒ Assignment document with cover letter (3 Pages)
- ☒ Fee (see formula below)
- ☒ Form PTO-2038

Basic Fee \$770/385 \$ 770.00

Additional Fees:

Total number of claims: 13
in excess of 20: 0 times \$18/9 \$ 0.00

Number of independent claims: 3
in excess of 3: 0 times \$86/43 \$ 0.00

Multiple Dependent Claims \$290/145 \$ 0.00

Recording Fee \$40. \$ 40.00

TOTAL FEES FOR THE ABOVE APPLICATION \$ 810.00

In the event there is attached hereto no credit card form PTO-2038 or check, or there is an insufficient amount, please charge the fee to our Account No. 18-0002 and notify us accordingly.

The right of priority is claimed under 35 USC §119 of Taiwanese Application No. 092112761, filed May 9, 2003.

Respectfully submitted,



Steven M. Rabin (Reg. No. 29,102)
Customer No. 23995

October 7, 2003

Date

SMR:tl

15915 U.S. PTO
100703

19270 U.S. PTO
10/679333
100703

FEE ENCLOSED: \$ 810.00
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